

# Tsung-Ting Kao

## List of Publications by Year in descending order

Source: <https://exaly.com/author-pdf/2144855/publications.pdf>

Version: 2024-02-01

15

papers

347

citations

840776

11

h-index

996975

15

g-index

15

all docs

15

docs citations

15

times ranked

472

citing authors

#	ARTICLE	IF	CITATIONS
1	Sub 250nm deep-UV AlGaN/AlN distributed Bragg reflectors. <i>Applied Physics Letters</i> , 2017, 110, .	3.3	29
2	High-Responsivity GaN/InGaN Heterojunction Phototransistors. <i>IEEE Photonics Technology Letters</i> , 2016, 28, 2035-2038.	2.5	17
3	Radiative recombination in GaN/InGaN heterojunction bipolar transistors. <i>Applied Physics Letters</i> , 2015, 107, 242104.	3.3	2
4	Growth of high-quality AlN layers on sapphire substrates at relatively low temperatures by metalorganic chemical vapor deposition. <i>Physica Status Solidi (B): Basic Research</i> , 2015, 252, 1089-1095.	1.5	46
5	Inverse-Tapered p-Waveguide for Vertical Hole Transport in High-[Al] AlGaN Emitters. <i>IEEE Photonics Technology Letters</i> , 2015, 27, 1768-1771.	2.5	9
6	GaN/InGaN avalanche phototransistors. <i>Applied Physics Express</i> , 2015, 8, 032101.	2.4	20
7	Temperature-Dependent Characteristics of GaN Homojunction Rectifiers. <i>IEEE Transactions on Electron Devices</i> , 2015, 62, 2679-2683.	3.0	19
8	A Remote-Oxygen-Plasma Surface Treatment Technique for III-Nitride Heterojunction Field-Effect Transistors. <i>IEEE Transactions on Electron Devices</i> , 2014, 61, 493-497.	3.0	16
9	Optically pumped AlGaN quantum-well lasers at sub-250 nm grown by MOCVD on AlN substrates. <i>Physica Status Solidi C: Current Topics in Solid State Physics</i> , 2014, 11, 258-260.	0.8	13
10	AlGaN-Based Vertical Injection Laser Diodes Using Inverse Tapered p-Waveguide for Efficient Hole Transport. <i>IEEE Journal of Quantum Electronics</i> , 2014, 50, 166-173.	1.9	14
11	Theoretical analysis of strategies for improving p-type conductivity in wurtzite III-nitride devices for high-power optoelectronic applications. <i>Physica Status Solidi C: Current Topics in Solid State Physics</i> , 2014, 11, 828-831.	0.8	4
12	Deep-ultraviolet lasing at 243nm from photo-pumped AlGaN/AlN heterostructure on AlN substrate. <i>Applied Physics Letters</i> , 2013, 102, .	3.3	77
13	Sub-250nm low-threshold deep-ultraviolet AlGaN-based heterostructure laser employing HfO <sub>2</sub> /SiO <sub>2</sub> dielectric mirrors. <i>Applied Physics Letters</i> , 2013, 103, .	3.3	36
14	Stimulated emission at 257nm from optically-pumped AlGaN/AlN heterostructure on AlN substrate. <i>Physica Status Solidi (A) Applications and Materials Science</i> , 2013, 210, 1768-1770.	1.8	7
15	Effects of a step-graded Al <sub>x</sub> GaN electron blocking layer in InGaN-based laser diodes. <i>Journal of Applied Physics</i> , 2011, 109, .	2.5	38